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# **AMENDMENT TRANSMITTAL LETTER**

Docket No. KWM-0001

Application No. 10/088,163

Filing Date March 15, 2002 Examiner P. Greene

Art Unit 2826

Applicant(s): Kazutaka SHIBATA

Invention:

SEMICONDUCTOR DEVICE WITH CHIP-ON-CHIP CONSTRUCTION JOINED VIA A LOW-

MELTING POINT METAL LAYER (AS AMENDED)

### TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

		CLAIM	S AS AMENI	DED	
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	33	- 35 =		х	0.00
Independent Claims	4	- 6 =		х	0.00
Multiple Depend	dent Claims (ch	eck if applicabl	le)		
Other fee (pleas	e specify):				
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					0.00
x Large Entity Small Entity					ty
x No additiona	al fee is require	d for this ame	ndment.		
A duplicate	copy of this she	eet is enclosed	1.	n the amount of \$	
A check in the	ne amount of \$		to cover	the filing fee is er	closed.
Payment by	credit card. Fo	orm PTO-2038	is attached.		
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x Credit a	ny overpaymer	nt.			
x Charge a	any additional fil	ing or application	n processing t	ees required unde	r 37 CFR 1.16 and 1.17.
Carl Schaukow	hankruntt			Dated:	March 13, 2003
Attorney Reg. N					
RADER, FISHN 1233 20th Stree Suite 501		R PLLC	· - ·		
Washington, Do					Ž.
(202) 955-3750 Customer No.					, other

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S. C.

### PATENT APPLICATION

Attorney Docket No.: KWM-0001

Examiner: P. Greene

Confirmation No. 1108

Art Unit: 2826

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kazutaka SHIBATA

Application No.: 10/088,163

Filed: March 15, 2002

SEMICONDUCTOR DEVICE WITH CHIP-ON-CHIP CONSTRUCTION JOINED

VIA A LOW-MELTING POINT METAL LAYER (As Amended)

AMENDMENT UNDER 37 C.F.R. §1.111

**BOX NON-FEE AMENDMENT** 

Commissioner for Patents Washington, DC 20231

Sir:

For:

In response to the Office Action dated December 18, 2002, please and the above-identified application as follows:

### IN THE SPECIFICATION:

Please change the title of the invention as set forth below in clean form. Additionally, in accordance with 37 CFR 1.121(b)(1)(iii), the changed title is set forth in a marked-up version in the page(s) attached to this Amendment.

On Page 1, before Paragraph 1:

SEMICONDUCTOR DEVICE WITH CHIP-ON-CHIP CONSTRUCTION
JOINED VIA A LOW-MELTING POINT METAL LAYER

### **IN THE CLAIMS:**

Please cancel claims 21-24 without prejudice or disclaimer.

Please amend claims 1-6, 10, 12 and 18 as set forth below in clean form. Additionally, in accordance with 37 CFR 1.121(c)(1)(ii), the amended claim(s) are set forth in a marked-up version in the page(s) attached to this Amendment.

(Amended) A semiconductor device comprising:
 a first semiconductor chip having an electrode terminal:

